



[10191/3980]

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER
Serial No. : 10/519,724
Filed : December 28, 2004
For : DEVICE AND METHOD FOR THE PRODUCTION OF
CHLORINE TRIFLUORIDE AND SYSTEM FOR
ETCHING SEMICONDUCTOR SUBSTRATES USING
THIS DEVICE
Examiner : Rakesh Dhingra
Art Unit : 1763
Confirmation No. : 5180

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on:

Date:

July 30, 2007

Signature:

Chilul

AMENDMENT

S I R:

In response to the Office Action of March 28, 2007, kindly amend the above-captioned application without prejudice as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

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